



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of: **HAYASHI, et al.**

Group Art Unit: 2813

Serial No.: **09/955,600**

Examiner: **Tuan H. Nguyen**

Filed: **September 19, 2001**

Confirmation No.: **1668**

For: **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING  
THE SAME AND METHOD OF FORMING NITRIDE BASED  
SEMICONDUCTOR LAYER**

Attorney Docket Number: **990852A**  
Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

September 3, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 5, 2004 for three months from June 5, 2004 to September 5, 2004.

Attached please find a check in the amount of \$950.00 to cover the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

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Stephen G. Adrian

Attorney for Applicants  
Registration No. 32,878  
Telephone: (202) 822-1100  
Facsimile: (202) 822-1111

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